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Electronic Patent Application Submission
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EFS ID: 63000

Application ID: 10811624



Title of Invention:

METHOD OF SELF-ALIGNING AN
OXIDE APERTURE WITH AN
ANNULAR INTRA-CAVITY
CONTACT IN A LONG
WAVELENGTH VCSEL

First Named Inventor: Leo CHIROVSKY

Domestic/Foreign Application: Domestic Application

Filing Date: 2004-03-29

Effective Receipt Date: 2004-06-21

Submission Type: Information Disclosure
Statement

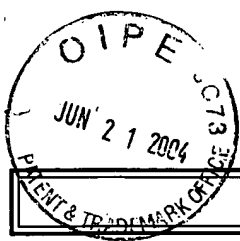
Filing Type:

Confirmation number: 2731


Attorney Docket Number: 0013P00903US2

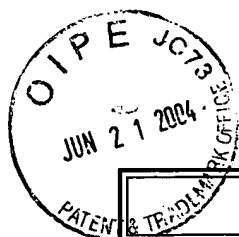
Total Fees Authorized:

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**TRANSMITTAL**

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention	METHOD OF SELF-ALIGNING AN OXIDE APERTURE WITH AN ANNULAR INTRA-CAVITY CONTACT IN A LONG WAVELENGTH VCSEL									
<p>Application Number: 10/811624 </p> <p>Date: 2004-03-29</p> <p>First Named Applicant: Mr. Leo M. CHIROVSKY</p> <p>Confirmation Number: 2731</p> <p>Attorney Docket Number: O013P00903US2</p>										
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<table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>Mr. Stephen J. Holmes Registered Number: 34621</td><td>/stephen.j.holmes/</td><td>Attorney</td></tr></tbody></table>			Submitted by:	Elec. Sign.	Sign. Capacity	Mr. Stephen J. Holmes Registered Number: 34621	/stephen.j.holmes/	Attorney		
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<table><tr><td>Documents being submitted</td><td>Files</td></tr><tr><td>us-ids</td><td>P00903US2-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			Documents being submitted	Files	us-ids	P00903US2-usidst.xml		us-ids.dtd		us-ids.xsl
Documents being submitted	Files									
us-ids	P00903US2-usidst.xml									
	us-ids.dtd									
	us-ids.xsl									
Comments										



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

**METHOD OF SELF-ALIGNING AN OXIDE APERTURE
WITH AN ANNULAR INTRA-CAVITY CONTACT IN A LONG
WAVELENGTH VCSEL**

Application Number: 10/811624



Confirmation Number: 2731

First Named Applicant: Leo CHIROVSKY

Attorney Docket Number: O013P00903US2

Art Unit: 2812

Search string: (5985683 or 5991326 or 6075804 or 6169756
or 6411638 or 6618414 or 20020090016 or
20020101894 or 20020131462 or 20020150135
or 20030031221 or 20030185267 or
20040058467).pn.

US Patent Documents

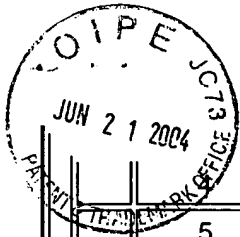
Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5985683	1999-11-16	Jewell		438	22
	2	5991326	1999-11-23	Yuen et al.		372	96
	3	6075804	2000-06-13	Deppe et al.		372	96
	4	6169756	2001-01-02	Chirovsky et al.	B1	372	46
	5	6411638	2002-06-25	Johnson et al.	B1	372	46
	6	6618414	2003-09-09	Wasserbauer et al.	B1	372	45

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20020090016	2002-07-11	Coldren et al.	A1	372	96
	2	20020101894	2002-08-01	Coldren et al.	A1	372	43
	3	20020131462	2002-09-19	Lin et al.	A1	372	43



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	5	20030031221	2003-02-13	Wang	A1	372	45
	6	20030185267	2003-10-02	Hwang et al.	A1	372	96
	7	20040058467	2004-03-25	Chirovsky et al.	A1	438	32

Signature

Examiner Name	Date